

On the Perils of Unexpected Silane Generation

Abstract:

A number of functional group reductions reported in the literature utilize mixtures of triethoxysilane [(EtO)₃SiH] and Lewis acids. It should be noted that this combination can produce the highly pyrophoric and toxic gas, silane (SiH₄).

Over the past number of years, several safety alerts have been published concerning hazards related to the unexpected generation of silane, SiH₄, in chemical reactions. For example, see the reports in *Chemical & Engineering News* (C&EN).¹ These alerts are related to publications pertaining to the preparation of hydride-capped silicon nanoparticles by the reduction of SiCl₄ with LiAlH₄ in ethereal solvents.² The initial publications apparently failed to mention that this procedure could lead to the release of SiH₄, an extremely dangerous, toxic, pyrophoric, and explosive gas (TLV-TWA 5 ppm, flammable in air between 1 and 96% v/v).³ Whilst this material can be generated and handled safely on a large scale with appropriate safety and engineering controls, its unexpected generation in a standard organic chemistry facility can lead to serious hazards to workers and risks to infrastructure. A 1% silane mix in nitrogen is flammable in air.³ It is of interest to note that the efficient generation of SiH₄, GeH₄, and SnH₄ from their respective tetrachlorides and LiAlH₄ was reported as long ago as 1947.⁴ It would be assumed (hoped) that any competent and well-trained synthetic organic chemist would recognize the potential for SiH₄ generation from SiCl₄ and LiAlH₄. However, this highly hazardous material can also be generated by a less apparent, insidious pathway.

These C&EN news reports recall an incident several years ago in which a highly pyrophoric and explosive gas (presumed to be SiH₄) was unexpectedly generated.⁵ The reaction under investigation was the selective reduction of methyl-11-bromo-undecanoic ester to 11-bromo-undecanol. This had been done successfully on pilot scale using BH₃–THF. However, for large-scale manufacture, a more economical but still selective reductant was sought. A paper was located describing the reduction of esters to alcohols in the presence of other reducible groups, including primary alkyl bromides, with (EtO)₃SiH and Ti(i-PrO)₄ as a catalyst.⁶ This procedure was tried on a millimolar scale. The reaction proceeded without incident, and the product was isolated in very high yield and excellent purity,

exactly as described in the literature.⁶ The reaction was then scaled up to multigram scale with quite a different outcome. Shortly after the reagents were mixed, an extremely exothermic reaction began with a highly pyrophoric gas being generated. The incident terminated when the reaction vessel exploded, resulting in the destruction of all the surrounding contents in the fume hood.⁵ Whilst never unambiguously proven, the most likely cause of this incident was the disproportionation of the (EtO)₃SiH to mixtures of (EtO)_xSiH_y including SiH₄.⁵

Occasionally the combination of (EtO)₃SiH and Lewis acid has been reported for the reduction of functional groups other than esters. For example, phosphine oxides to phosphines [(EtO)₃SiH + Ti(OiPr)₄],⁷ reductive etherification [(EtO)₃SiH + InCl₃/TMSCl],⁸ reduction of ketones [(EtO)₃SiH + ZnI₂]⁹ and the latest being the reduction of amides to amines [(EtO)₃SiH + Zn(OAc)₂]¹⁰—a reaction that could be very attractive as a greener alternative to LiAlH₄ or BH₃ reduction for the synthesis of amines. It should be noted that the large-scale synthesis of SiH₄ is via the Lewis acid- or Lewis base-catalysed disproportion of HSiCl₃,^{11,12} and there are reports in the literature of (EtO)₃SiH as a SiH₄ precursor in the presence of various catalysts and in the absence of a reducible substrate.¹³ However, it should *never* be assumed that reaction mixtures containing reducible substrates, (EtO)₃SiH and Lewis acids, will not generate SiH₄, and the use and scale-up of any such process should be undertaken with great caution and with high regard for potential hazards of unexpected generation of SiH₄. Safer alternatives to (EtO)₃SiH that cannot lead to SiH₄ generation should always be considered before the use of (EtO)₃SiH. Some examples are tetramethyldisiloxane¹⁴ and polymethylhydro-siloxane.^{7,15}

Note Added after Proof: A correction to reference 10 has just been published.¹⁶

Andrew S. Wells

*Chemical Sciences, Pharmaceutical Development,
AstraZeneca, Bakewell Road, Loughborough,
Leicestershire, U.K. LE11 5RH. E-mail:
Andrew.wells@astrazeneca.com*

OP100080V

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